

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/812,765	ARAI ET AL.	
Examiner	Art Unit	
Wen-Ying P. Chen	2871	

SEARCHED					
Class	Subclass	Date	Examiner		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Key word and citations search on EAST: see search history.	7/20/2005	WPC